



04-2203

MEMC 98-4650 (2293)
PATENT

RCE/1700

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4/24/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Gregory Michael Wilson et al. Art Unit 1765
Serial No. 09/608,302
Filed June 30, 2000
Confirmation No. 9819
For A METHOD AND APPARATUS FOR FORMING SILICON WAFER WITH A
DENUDED ZONE
Examiner Robert M. Kunemund

April 21, 2003

REQUEST FOR CONTINUED EXAMINATION TRANSMITTAL

TO THE ASSISTANT COMMISSIONER FOR PATENTS,

SIR:

This is a Request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application.

1. REQUIRED SUBMISSION:

- a. Previously submitted
 - i. Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on _____
 - ii. Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
 - iii. Other _____
- b. Enclosed
 - i. Amendment/Reply
 - ii. Affidavit(s)/Declaration(s)
 - iii. Information Disclosure Statement
 - iv. Other (3 drawings) _____

2. MISCELLANEOUS

- a. Suspension of action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of _____ months. (Period of suspension shall not exceed 3 months; fee required)
- b. Other _____

3. FEES (Required when the RCE is filed)

- a. The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No. 19-1345:
 - i. RCE fee required under 37 C.F.R. §1.17(e)

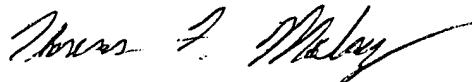
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02 FC:1251

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TC 1700

ii. Extension of time fee
iii. Other _____

b. Check in the amount of \$860.00 is enclosed, along with a Fee Transmittal

Respectfully submitted,



Thomas F. Maloney, Reg. No. 50,156
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

Express Mail Label No. EL 890685436 US
Box RCE